Search Notes					

Application/Control No.	Applicant(s)/Patent under Reexamination
10/772,212	LIEN ET AL.
Examiner	Art Unit
Lisa M. Caputo	2876

SEARCHED					
Class	Subclass	Date	Examiner		
235	375 380 382	5/26/2006	LMC		
705	16-18	5/26/2006	LMC		
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INTERFERENCE SEARCHED				
Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
General Keyword Search	5/26/2006	LMC
EAST Update Search attached	5/26/2006	LMC
NPL (Internet) Search	5/26/2006	LMC